

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

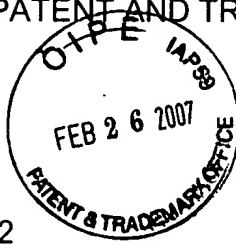
In re the Application of:

Hiroshi TAKENO

Application No.: 09/926,202

Filed: September 24, 2001

For: MANUFACTURING PROCESS FOR SILICON EPITAXIAL WAFER



Confirmation Number: 6219

Group Art Unit: 1722

Examiner: G. Nagesh Rao

Attorney Dkt. No.: 107242-00024

AMENDMENT UNDER 37 C.F.R §1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

February 26, 2006

Sir:

In reply to the September 15, 2006 Office Action, the period for response being extended to March 15, 2007, by the attached Petition for Extension of Time, please consider the following:

Amendments to the claims, as reflected in the listing of claims begins on page 2;

and

Remarks begin on page 4.